

Cautionary Note Regarding Forward Looking Statements

This presentation contains certain forward-looking statements within the meaning of Section 27A of the Securities Act of 1933 and Section 21E of the Securities Exchange Act of 1934 and Private Securities Litigation Reform Act, as amended, including those relating to the Company's product development, market opportunity, competitive position, possible or assumed future results of operations, business strategies, potential growth opportunities and other statements that are predictive in nature. These forward-looking statements are based on current expectations, estimates, forecasts and projections about the industry and markets in which we operate and management's current beliefs and assumptions.

These statements may be identified by the use of forward-looking expressions, including, but not limited to, "expect," "anticipate," "believe," "estimate," "potential," "predict," "project," "should," "would," and similar expressions and the negatives of those terms. These statements relate to future events or our financial performance and involve known and unknown risks, uncertainties, and other factors which may cause actual results, performance or achievements to be materially different from any future results, performance or achievements expressed or implied by the forward-looking statements. Such factors include those set forth in the Company's filings with the Securities and Exchange Commission. Prospective investors are cautioned not to place undue reliance on such forward-looking statements, which speak only as of the date of this presentation. The Company undertakes no obligation to publicly update any forward-looking statement, whether as a result of new information, future events or otherwise.





.....



The Crazy Frog













NOKIA







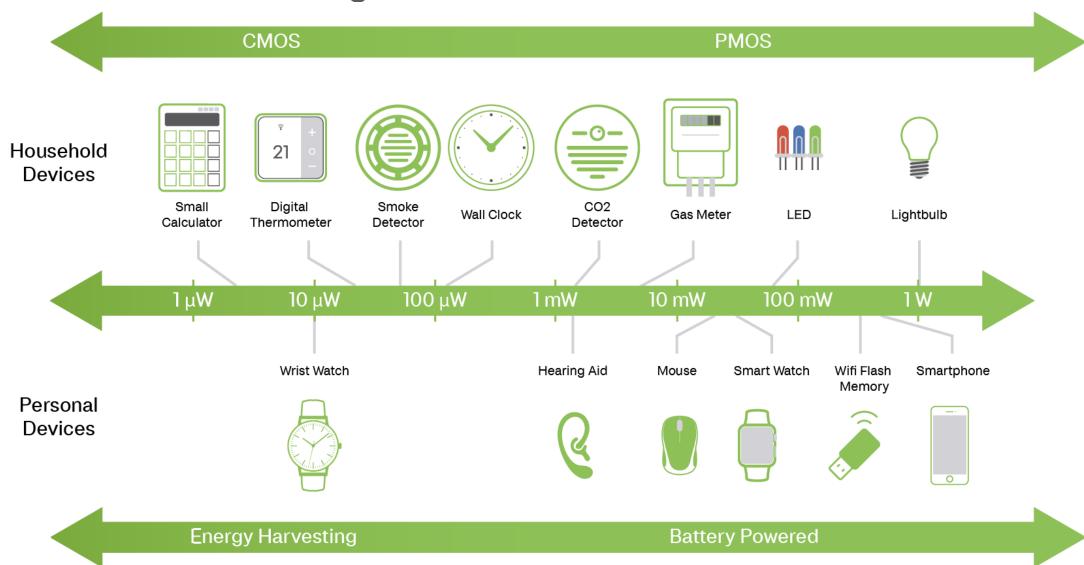
iPhone 2G





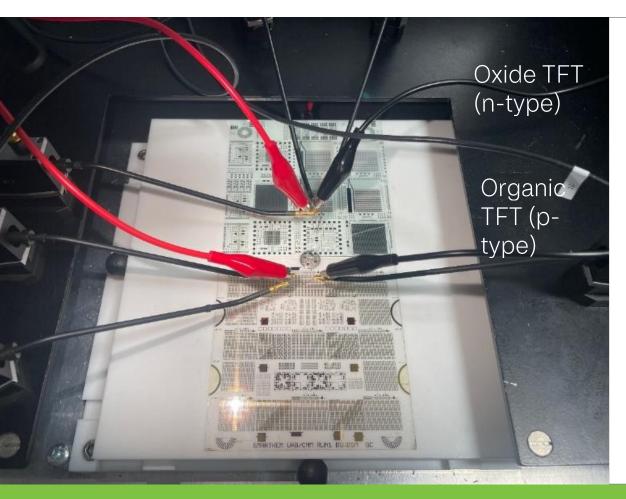
The Internet of Things

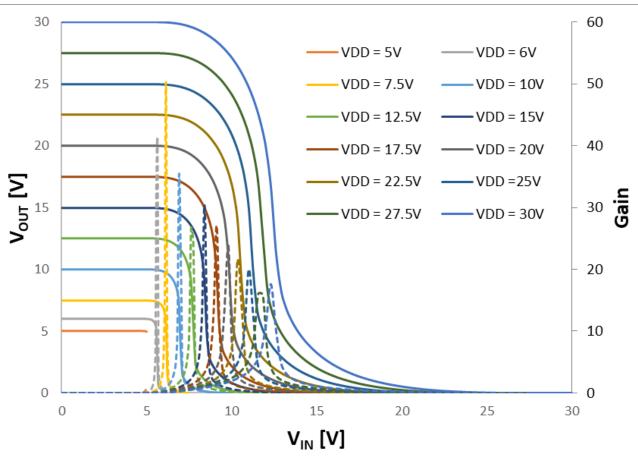
Market Size: \$544bn



Using OTFT and IGZO to make CMOS

Perfect Inversion



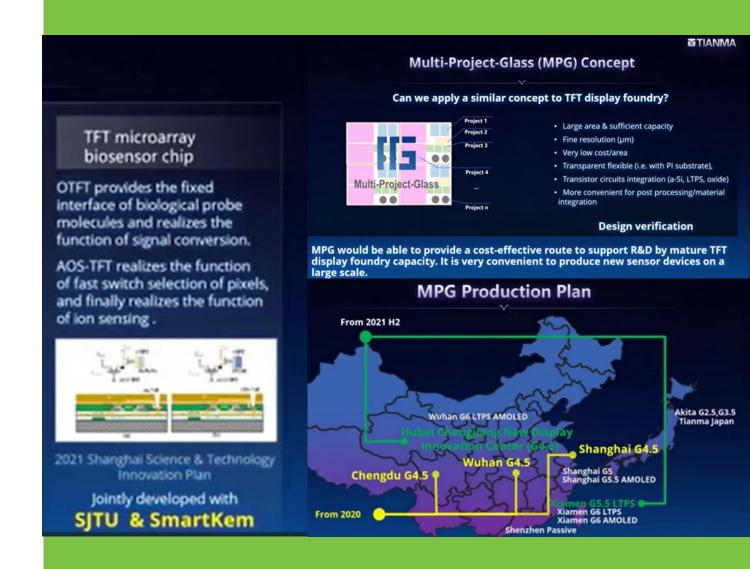


Tianma and SmartKem Cooperation for AOS and OTFT

TIANMA







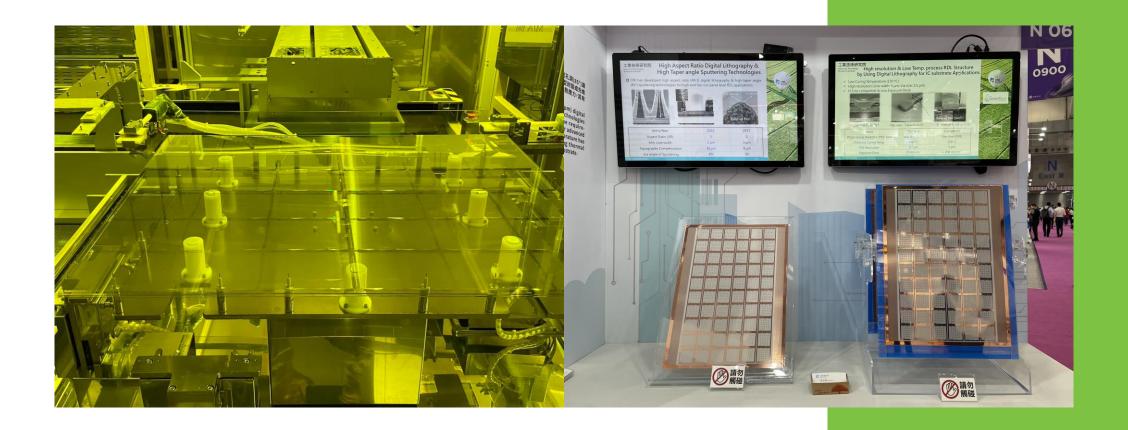
We manufacture "TRUFLEX®" inks used to make transistors



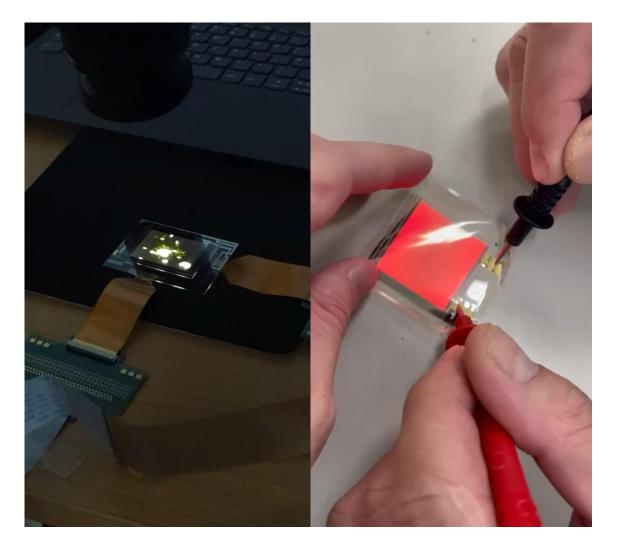
Sell materials, licence processes and fields of use



Single layer application

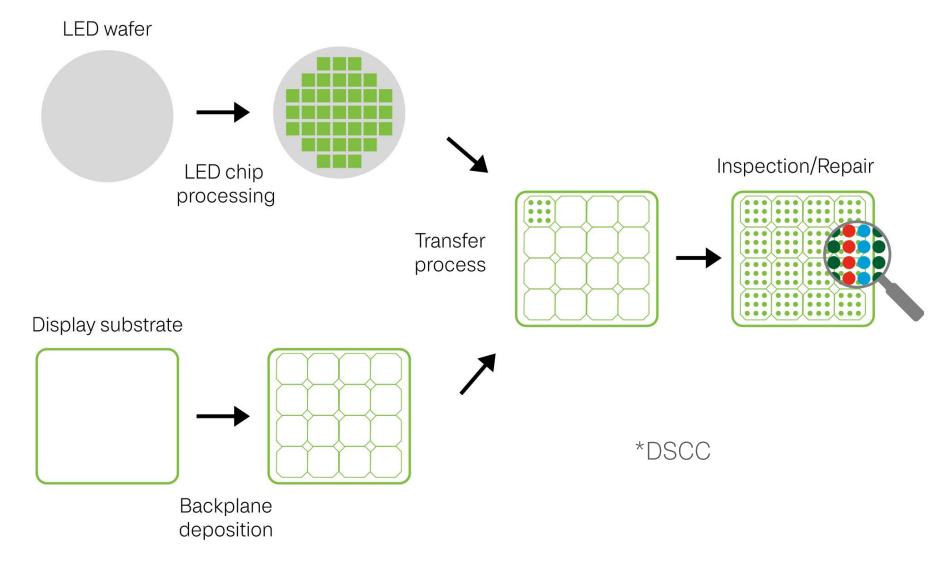


Transistor Backplanes



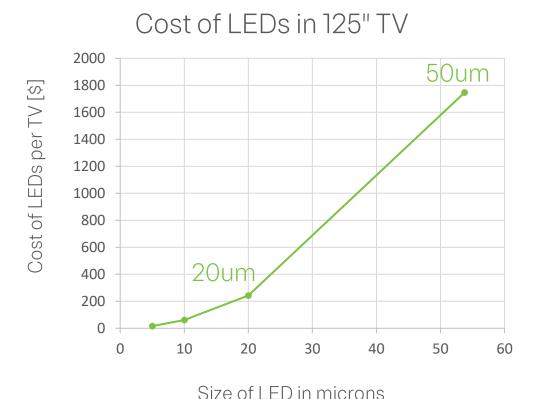


Making MicroLED Displays

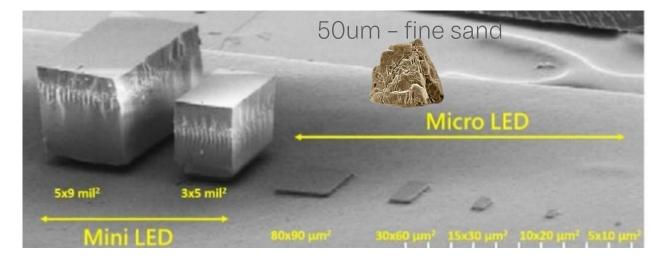




MicroLEDs need to be small to make them viable at large scale



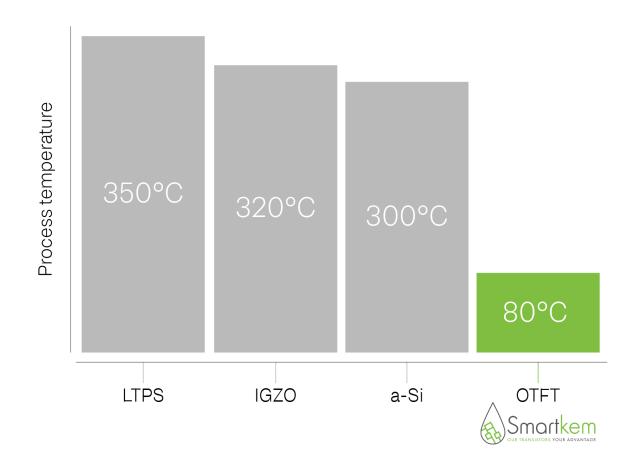
For microLED to be economical we need to be using <20 micron size LEDs for TV applications





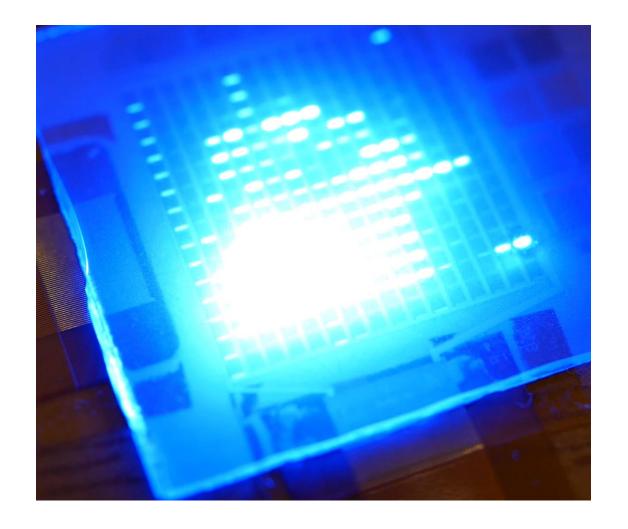
What's unique about SmartKem's transistors - Low processing temperature

- High temperature processing will damage LEDs
- SmartKem processes at 80°C
- Scalable solution-based process
- Uses existing manufacturing infrastructure



MicroLED Monolithically Integrated transistors - It works

- Low temperature process
- Standard process equipment
- Initial demos tested to >100K nits

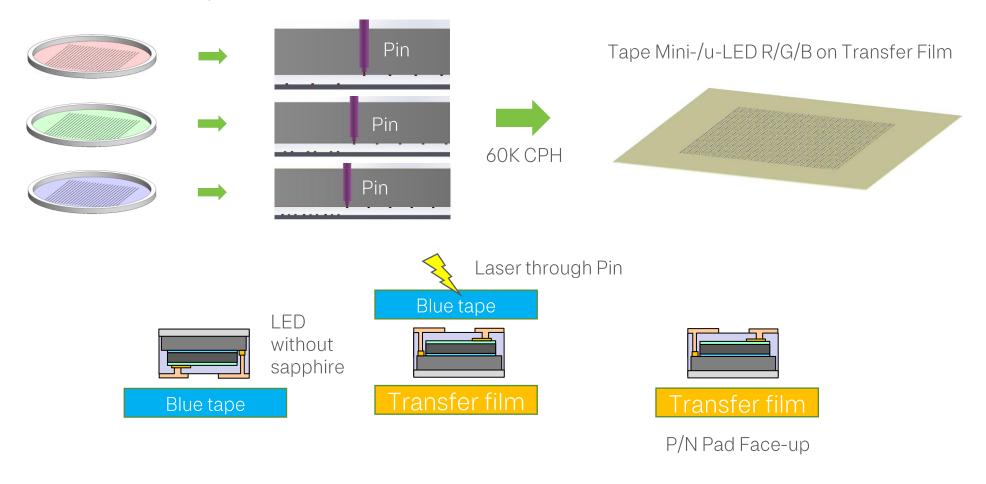




Mini/MicroLED Monolithically Integrated OTFT at large scale

Mini/MicroLED Chip on Transfer Film process

6inch Blue Tape Mini-/u-LED R/G/B

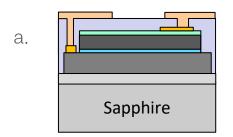


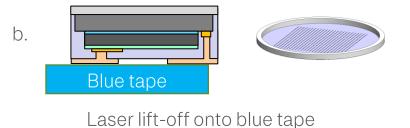


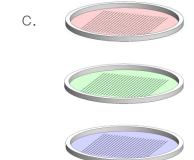
Reducing the µ-LED Cost

Part Transfer, Part Monolithic Process

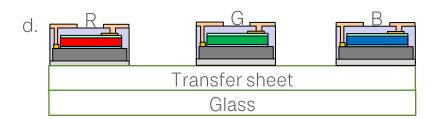
Processing OTFT on the transfer sheet will be the best way to achieve good display size scalability at low GaN cost



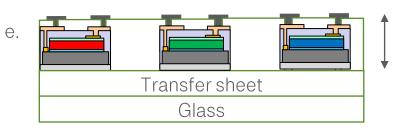




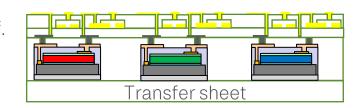
10um



Laser-induced forward transfer (LIFT) (pitch same as display)



Planarize, etch vias and metallize contacts



Low temperature OTFT backplane processed on top of LEDs



Advantages of chip first MicroLED displays

Lower cost emitters

Can use much smaller flip chip u-LEDs immediately 30x15um instead of 34x85um (84% reduction in GaN wafer cost)

Flexible microLED display

Transfer sheet is a flexible film that can be removed from the glass carrier

Monolithic single sided architecture

No side wiring required Driver attach
CoF can be on
TFT side (since light is emitted through the substrate)

Lower driver cost

Substrate scalability

OTFT can use a-Si line tools so can scale to larger Gen sizes if transfer sheet substrate can be made at larger size

Moves away from the constraints of an LTPS processing environment

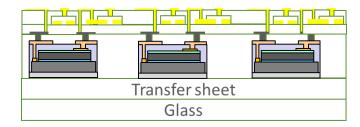
Option to move to larger Gen depreciated, lower processing cost (per m²) facilities

Higher yield

No laser anneal contact is made through metallized via in Interlayer Dielectric (ILD)

No thick In/Sn bumping or electroless nickel deposition required

No lift-off processes for patterning



SUMMARY

Best in class Organic Electronic Polymers that are used to make transistors arrays

Demonstrated the ability to drive AMOLED and MicroLED displays

Introducing a way of manufacturing Monlithic MicroLEDs at large scale



THANK YOU



Manchester Technology Center Hexagon Tower, Delaunays Road, Blackley, Manchester M9 8GQ UK

> +44 (0) 161 721 1514 enquiries@smartkem.com